

AMENDMENTS TO THE CLAIMS

The following listing of claims will replace all prior versions, and listing of claims in the application:

LISTING OF CLAIMS:

Claims 1 - 25 (canceled).

Claim 26 (currently amended) A method for removing polymer residues on sidewalls of metal lines, comprising:

providing a wafer with at least a metal line layer formed thereon, the sidewalls of the metal lines of the metal line layer having polymer residues formed thereon;

immersing said wafer in a stripping solution for removing the polymer residues in accordance with a first immersion time;

removing said wafer from said stripping solution and placing said wafer over said stripping solution at least ~~about~~ 100 seconds so as to render said stripping solution left on said wafer dripping down;

immersing said wafer in a first organic solvent for removing said stripping solution left on said wafer in accordance with a second immersion time;

removing said wafer from said first organic solvent and placing said wafer over said first organic solvent at least 50 seconds so as to render said stripping solution and said first organic solvent left on said wafer dripping down; immersing said wafer in a water flow for removing the stripping solution and said first organic solvent left on said wafer in accordance with a third immersion time; and removing water left on said wafer.

Claim 27 (original) The method of claim 26, wherein said first immersion time is about 10 minutes.

Claim 28(canceled).

Claim 29 (original) The method of claim 26, wherein said second immersion time is about 5 minutes.

Claim 30 (canceled).

Claim 31 (original) The method of claim 26, wherein said third immersion time is about 10 minutes.

Claim 32 (canceled).

Claim 33 (original) The method of claim 26, wherein said stripping solution comprises alcohol amine, water, dihydroxylbenzene, hydroxyl amine and anticorrosion agent.

Claim 34 (original) The method of claim 26, wherein said first organic solvent comprises alcohol (ROH).

Claim 35 (previously presented) The method of claim 34, wherein said alcohol is methanol.

Claim 36 (previously presented) The method of claim 34, wherein said alcohol is isopropyl alcohol.

Claim 37 (currently amended) The method of claim 26, ~~wherein prior to~~
~~immersing said wafer in said water flow,~~ further comprising steps of immersing said wafer in a second organic solvent for further removing said stripping solution left on said wafer in accordance with a fourth immersion time, and removing said wafer from said second organic solvent and placing said wafer over said second organic solvent at least 50 seconds so as to render said stripping solution, said first

organic solvent and said second organic solvent dripping down before immersing
said wafer in said water flow.

Claim 38 (original) The method of claim 37, wherein said fourth immersion time
is about 5 minutes.

Claim 39 (canceled).

Claim 40 (original) The method of claim 37, wherein said second organic
solvent comprises alcohol (ROH).

Claim 41 (original) The method of claim 40, wherein said second organic
solvent comprises methanol.

Claim 42 (original) The method of claim 40, wherein said second organic
solvent comprises isopropyl alcohol.

Claim 43 (currently amended) The method of claim 26, ~~wherein~~ further
comprising providing an inert gas flow in said first organic solvent.

Claim 44 (original) The method of claim 43, wherein said inert gas flow comprises nitrogen gas flow.

Claim 45 (original) The method of claim 43, wherein the flow rate of said inert gas flow is about 15 liters/per minute.

Claim 46 (original) The method of claim 44, wherein the flow rate of said nitrogen gas flow comprises 15 liters/per minute.

Claim 48 (original) The method of claim 47, wherein said inert gas flow comprises nitrogen gas flow.

Claim 49 (original) The method of claim 47, wherein the flow rate of said inert gas flow is about 15 liters/per minute.

Claim 50 (original) The method of claim 48, wherein the flow rate of said nitrogen gas flow is about 15 liters/per minute.